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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Mohamed N. Darwish; Frederick P. Giles; Kam Hong Lui; Kuo-In Chen; Kyle Terrill
Assignee: Siliconix incorporated
Title: Trench MIS Device With Reduced Gate-To-Drain Capacitance
Serial No.: Not Yet Known Filing Date: HEREWITH
Examiner: Not Yet Known Group Art Unit: Not Yet Known
Docket No.: M-11671 US



San Jose, California
August 10, 2001

BOX PATENT APPLICATION
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicant wishes to call to the attention of the Examiner the documents cited in the enclosed form PTO 1449 and the following documents:

1. U.S. Patent Application No. 09/591,179 Filed 6/8/00
Copies of the documents cited on the PTO 1449 and hereinabove are enclosed.
Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

EXPRESS MAIL LABEL NO:

EL 701 019 736 US

Respectfully submitted,

David E. Steuber
David E. Steuber
Attorney for Applicant(s)
Reg. No. 25,557

LAW OFFICES OF
SKJERVEN MORRILL
MACPHERSON LLP
25 METRO DRIVE
SUITE 200
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979